

Semiconductors



Product name

Discrete sensor High-Accuracy Position Sensors

Process and equipment name

Single wafer cleaning equipment

Model No.

## **Current Situation**

- Special cleaning processes require high-accuracy wafer positioning.
- Noncontact positioning is desirable.

K1G-\_\_\_

With many cleaning chambers, there is not much space for sensors.

## **Current Issues**

- Compact sensors using the light intensity method are not accurate enough.
- There is no room for high-accuracy 1D measuring devices or image sensors.
- With many chambers, sensors that are as inexpensive as possible are needed.



## Solutions



## Azbil Corporation

Advanced Automation Company

Yamatake Corporation changed its name to Azbil Corporation on April 1, 2012.

1-12-2 Kawana, Fujisawa Kanagawa 251-8522 Japan

URL: https://www.azbil.com

1st Edition : Nov. 2019-AZ